

03500.013395.2

PATENT APPLICATION

IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

In re Application of:)	
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KEISHI SAITO, ET AL.)	
	:	
Application No.: Not Yet Assigned)	
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Filed: Concurrently Herewith)	
	:	
For: SEMICONDUCTOR ELEMENT)	
AND ITS MANUFACTURING	:	
METHOD)	July 23, 2003

**This application is a divisional
under 37 C.F.R. § 1.53(b) of
U.S. Patent Appln. No. 09/839,891**

Mail Stop Patent Application
Commissioner for Patents
P.O. Box 1450
Alexandria, VA 22313-1450

CLAIM TO PRIORITY

Sir:

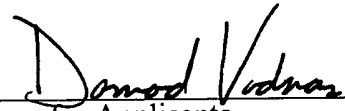
Applicants hereby claim priority under the International Convention and all rights to which they are entitled under 35 U.S.C. § 119 based upon the following Japanese priority applications:

Japan 10-065287, filed March 16, 1998; and
Japan 10-066854, filed March 17, 1998.

Certified copies of the priority documents were submitted in grandparent
Application No. 09/266,829.

Applicants' undersigned attorney may be reached in our Costa Mesa,
California office by telephone at (714) 540-8700. All correspondence should continue to
be directed to our address given below.

Respectfully submitted,



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